

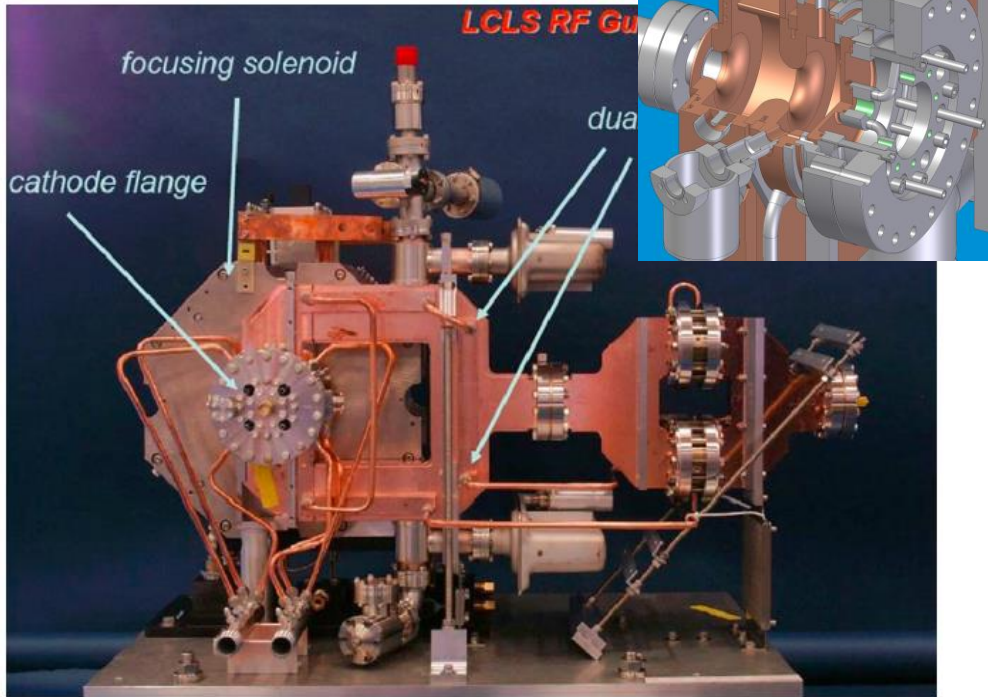
# SLAC Injector R&D

J. Schmerge for injector team  
October 24, 2016

- ❑ Status
- ❑ Motivation
- ❑ R&D approach
- ❑ Timeline and Budget
- ❑ Long term future

# LCLS gun and injector

R. Akre et al., PRSTAB 11, 030703 (2008)

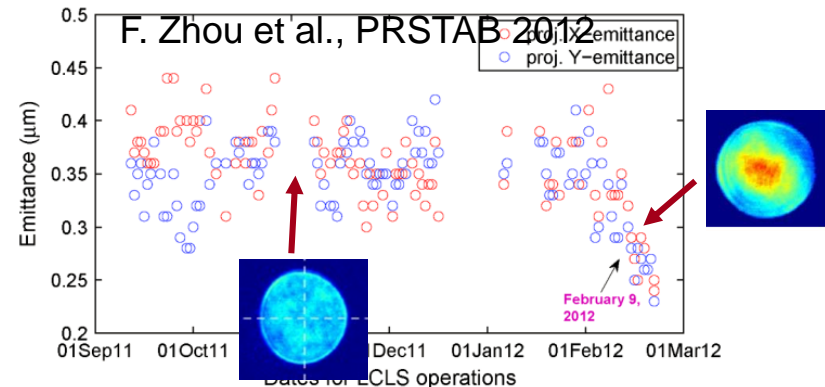


- Cathode laser cleaning

A. Brachmann et al., IPAC 2011

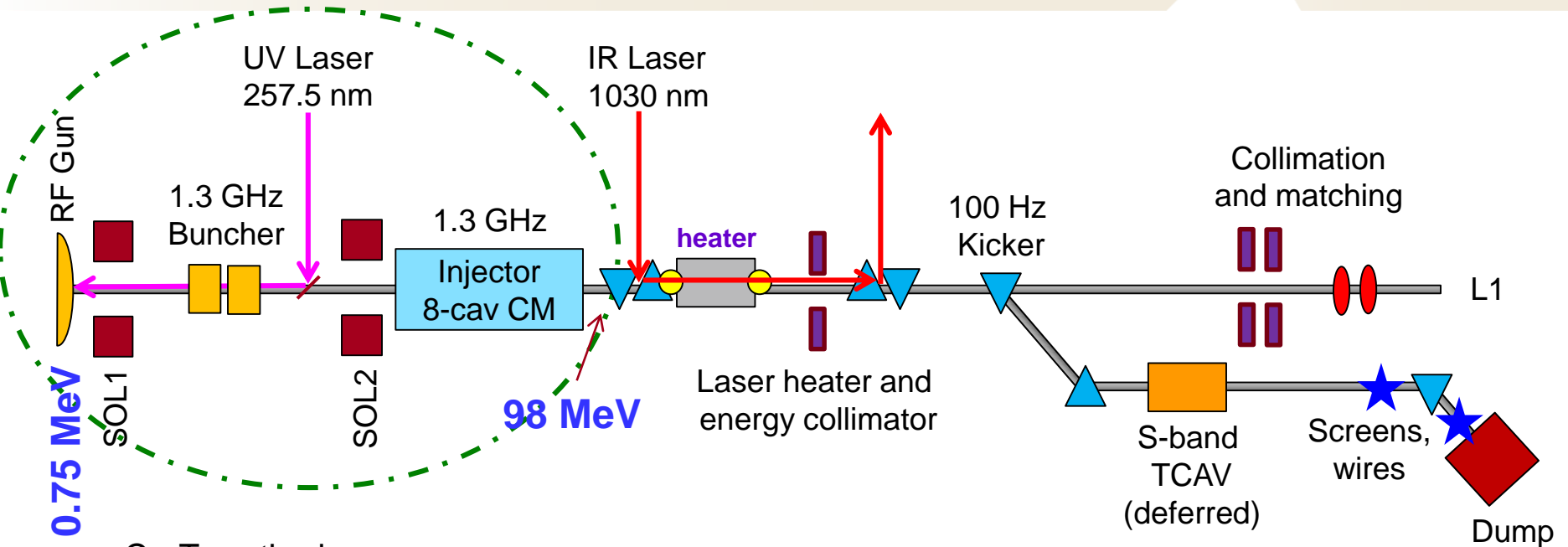
F. Zhou et al., PRSTAB 2012, NIMA 2015

- Transverse shaping



- Built on SLAC's technical excellence and GTF experience ('96-'05)
- Routine performance: 0.4-0.5  $\mu\text{m}$  emittance, 50 A current, 200 pC
- Highly successful, but we can do better

# LCLS-II CW (1MHz) injector

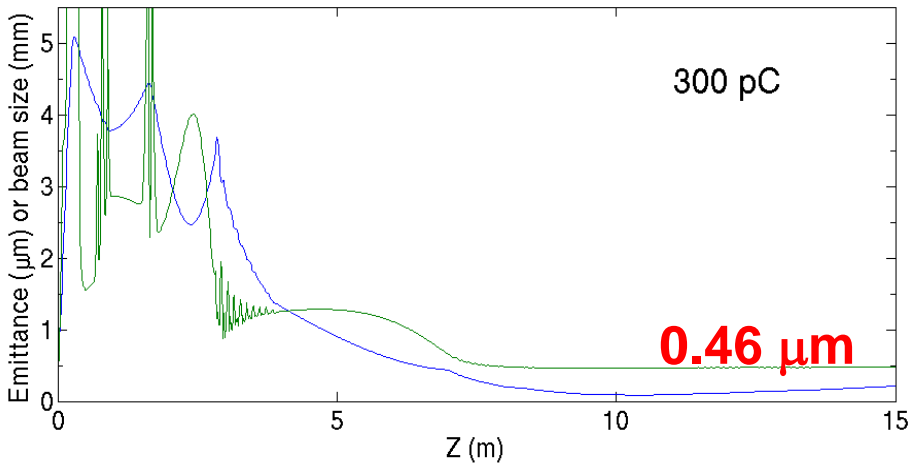
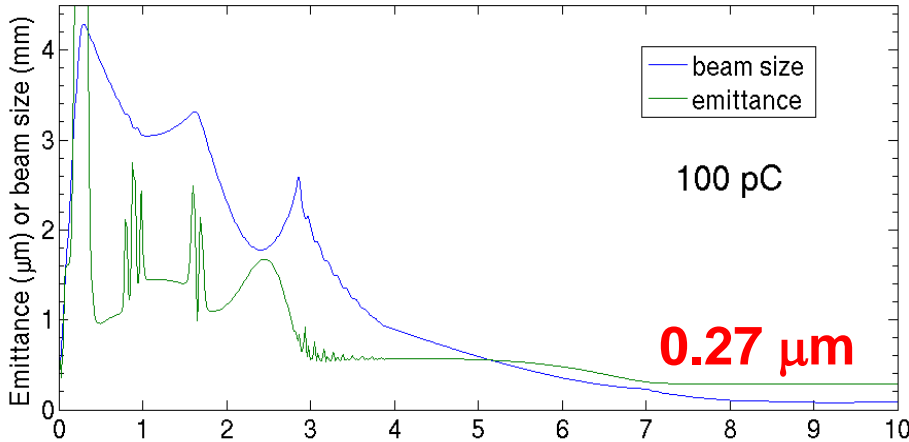


- Cs<sub>2</sub>Te cathode
- UV/IR lasers for cathode/laser heater
- 185.7 MHz NC RF gun
- NC 1.3 GHz 2-cell buncher
- SC 1.3 GHz 8-cavity CM
- 2 emittance compensating solenoids with quad correctors
- BPM Diagnostics

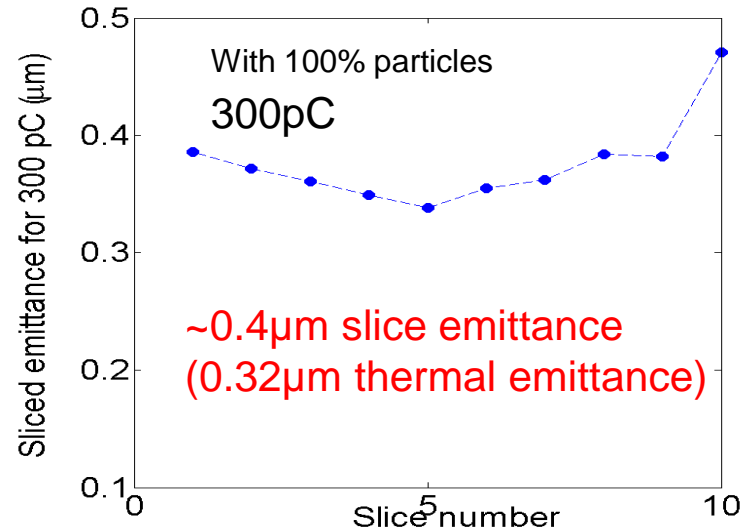
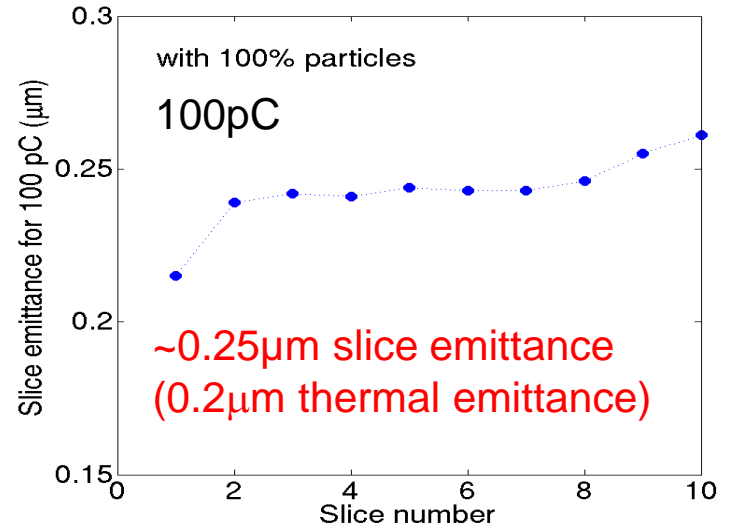
LCLSII-2.2-PR-0084-R0

# LCLS-II emittance

W/ Astra code

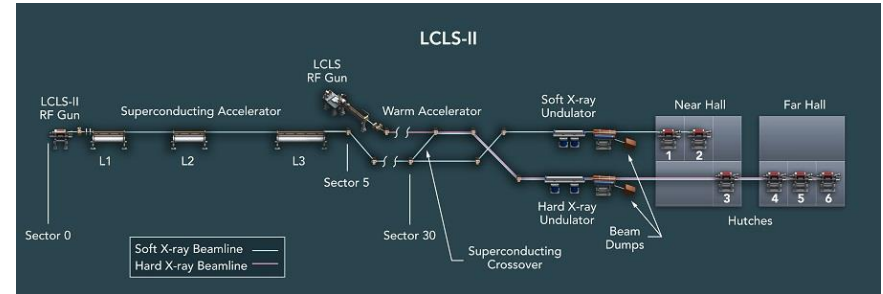


Assumes thermal emittance  $1\mu\text{m}/\text{mm}$



# Motivation

- **Lower Emittance** leads to *higher FEL power and increased spectral range*

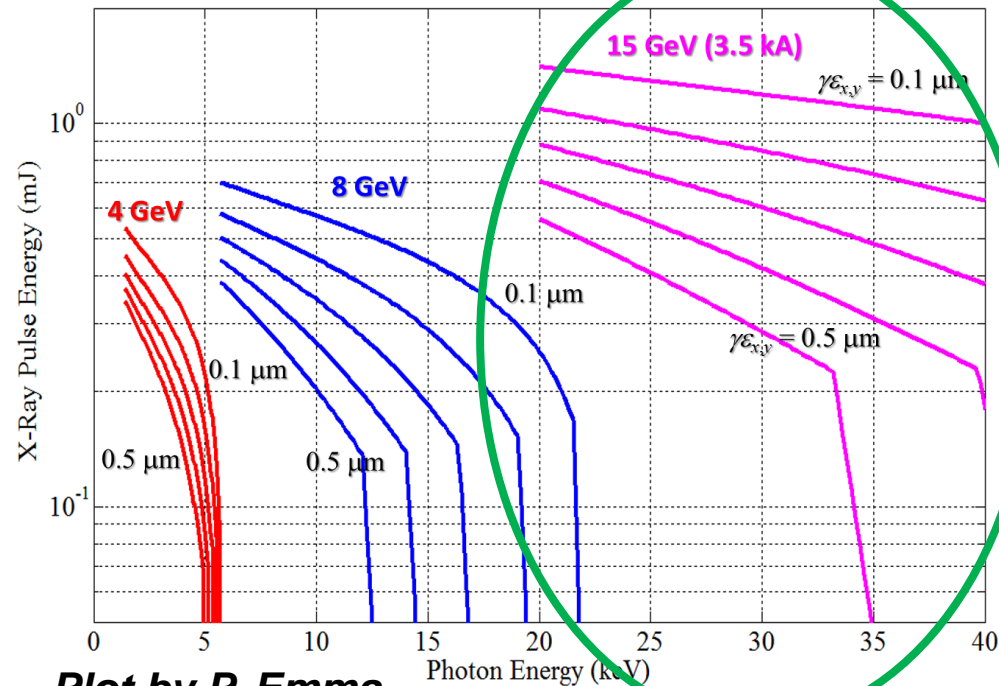


- **Improved Reliability**

- more consistent  $\epsilon_{thermal}$  and QE
- fast cathode swap
- Example is a load lock like originally planned for LCLS

- Benefits other programs also such as SLAC UED and FACET-II

HXR ( $\lambda_U=26$  nm) with SC-Linac (red, blue) & Cu-Linac (magenta) and emittance of 0.1, 0.2, 0.3, 0.4, and 0.5  $\mu\text{m}$



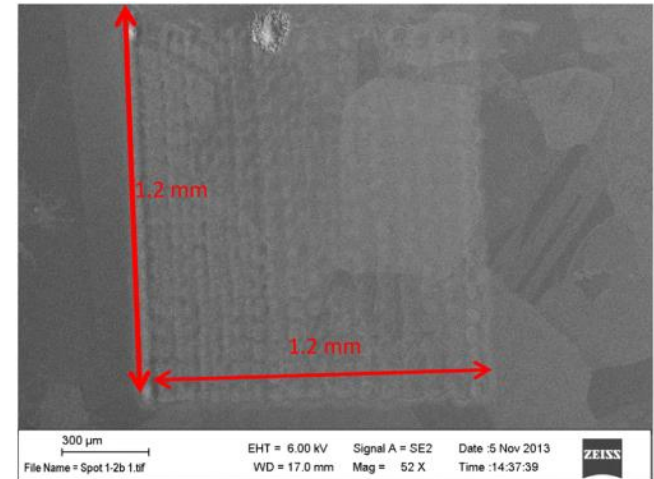
Plot by P. Emma

# How to Improve Brightness

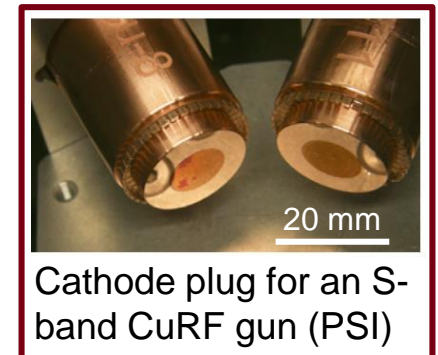
- ❑ Reduce thermal emittance
  - ❑ Smooth surface without laser cleaning
  - ❑ Wavelength dependence, temperature and single crystals
- ❑ Increase gradient
  - ❑ Novel structures
  - ❑ SRF guns
- ❑ Optimize
  - ❑ Pulse shaping
  - ❑ Match operational (200 pC) charge to injector design (1000 pC)

# Reduce Thermal Emittance

- Laser cleaning being used to restore QE, however cause surface roughness
- Roughness induced emittance growth not quantitatively studied
  - Roughness creates transverse fields which add transverse energy
- **Load-lock system** for the cathode
  - Preparation in better controlled environment
  - Vacuum cathode storage & transfer
  - Fast cathode swap



F. Zhou et al., NIMA 2015

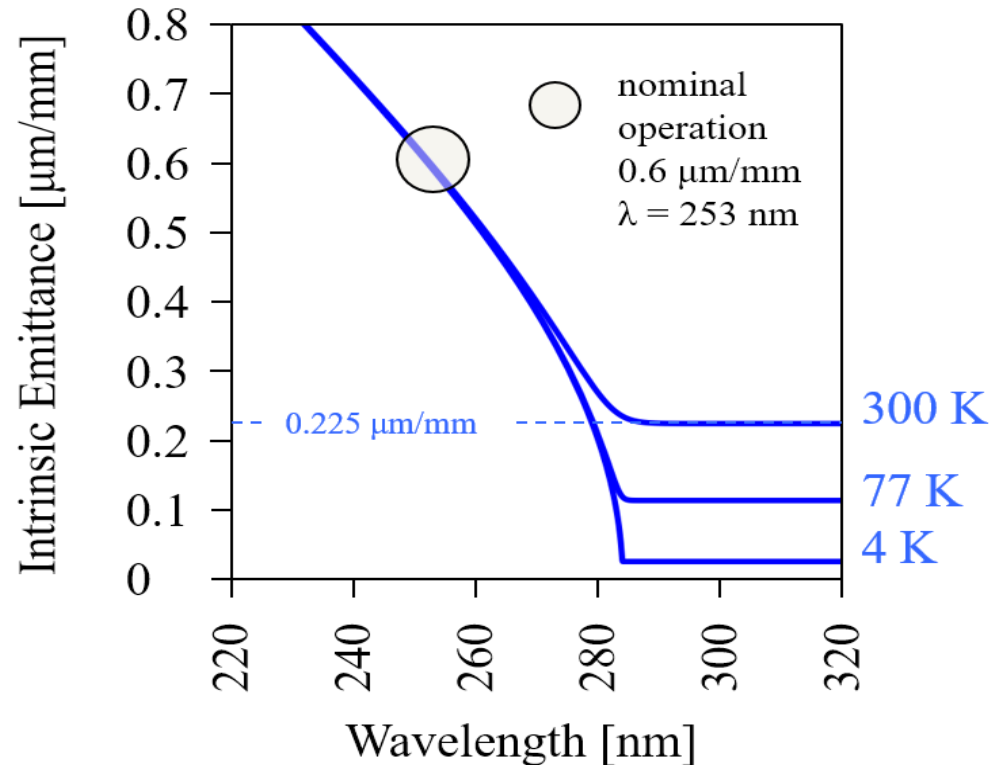


Cathode plug for an S-band CuRF gun (PSI)

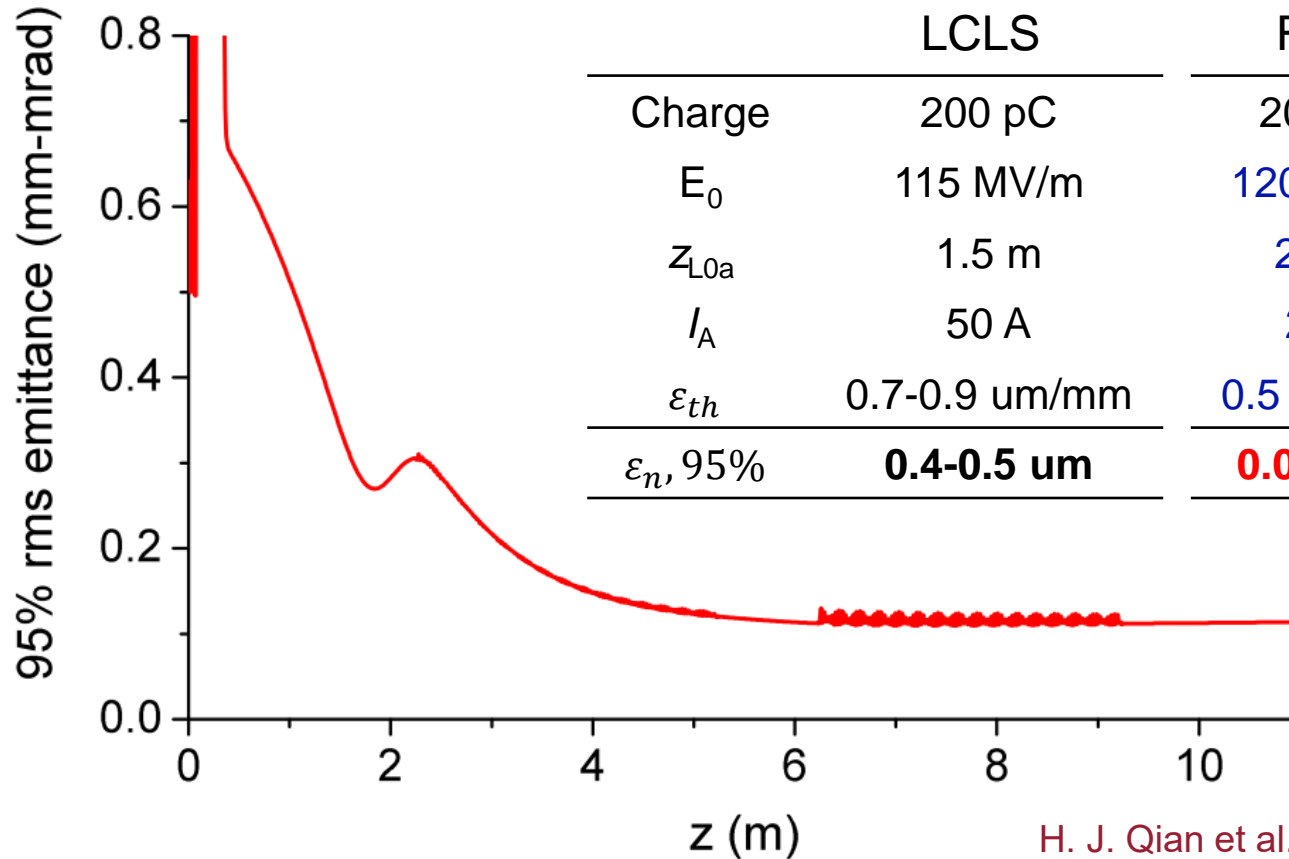


# Reduce Thermal Emittance

- Wavelength
- Temperature
- Crystal orientation dependence/polarization
- Semi-conductors
- Benefit from a load lock



*Plot by T. Vecchione*

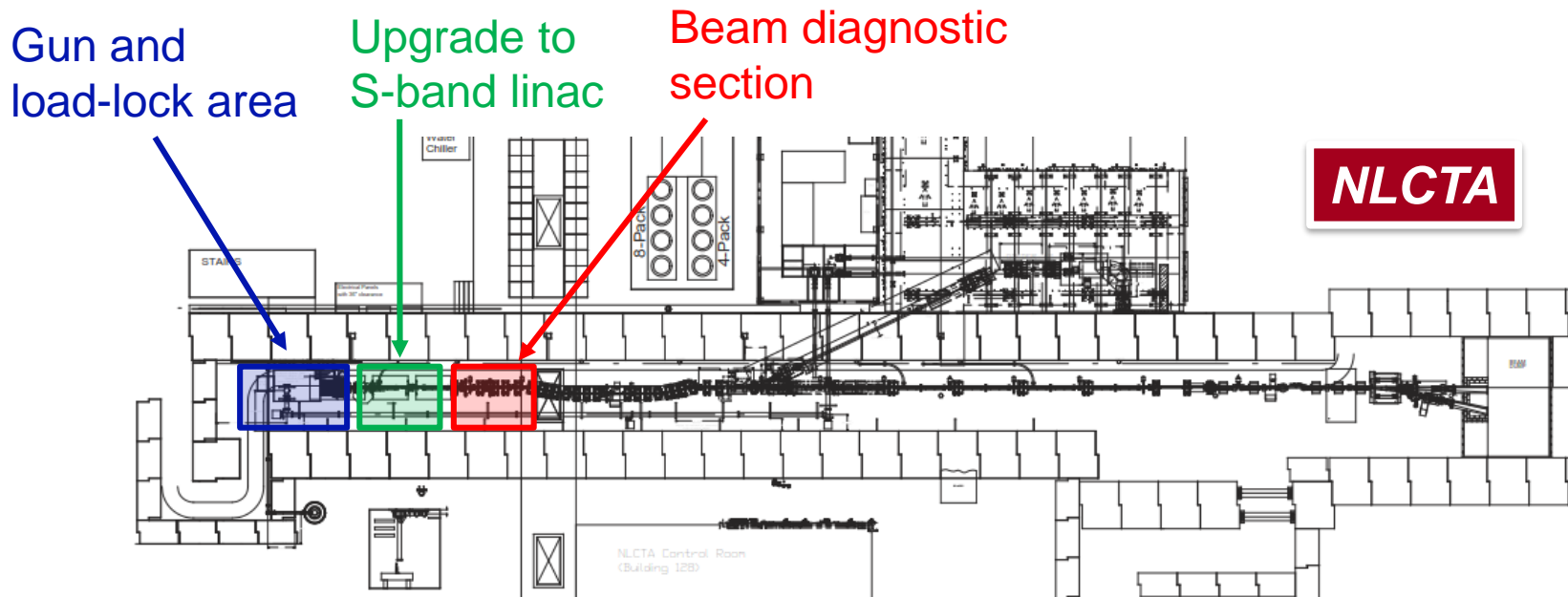


H. J. Qian et al., IPAC'16

- More detailed/systematic injector simulation ongoing
- Also studying emittance preservation for FEL (Panos, Yuantao, Zhirong)

# Test facility at NLCTA

- NLCTA (Next Linear Collider Test Accelerator) ideal candidate
- moderate upgrade needed: S-band dual-feed linac, etc.
- Laser improvements

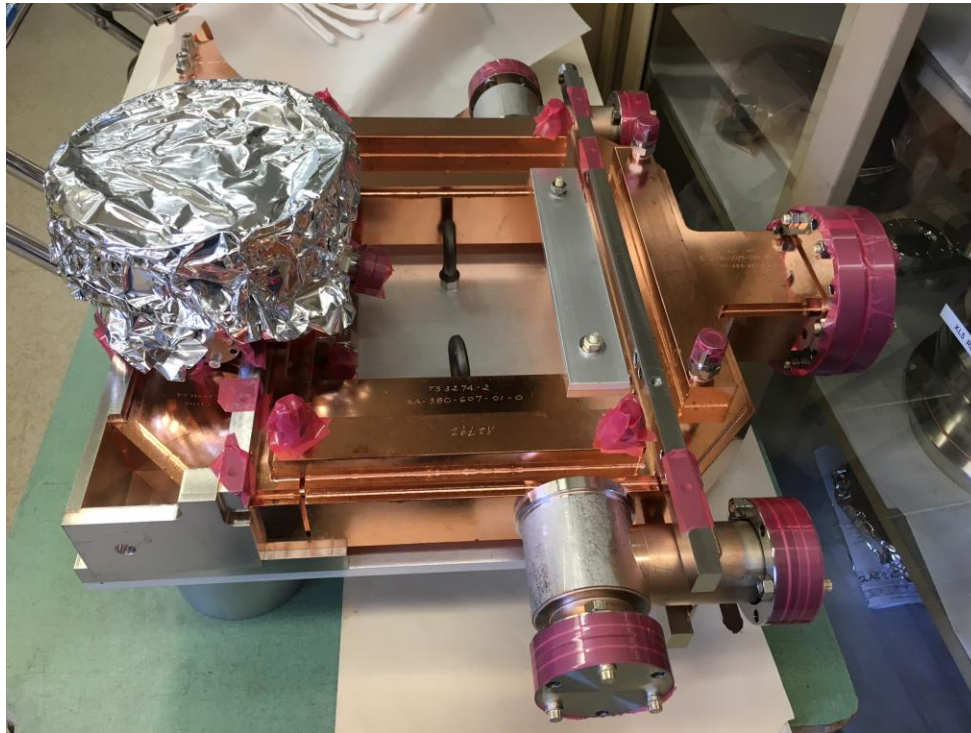


*M. Dunning*

# LCLS-I Spare Gun 2

*Final vacuum assembly and heater tape bake mid-September*

RF Window Spools

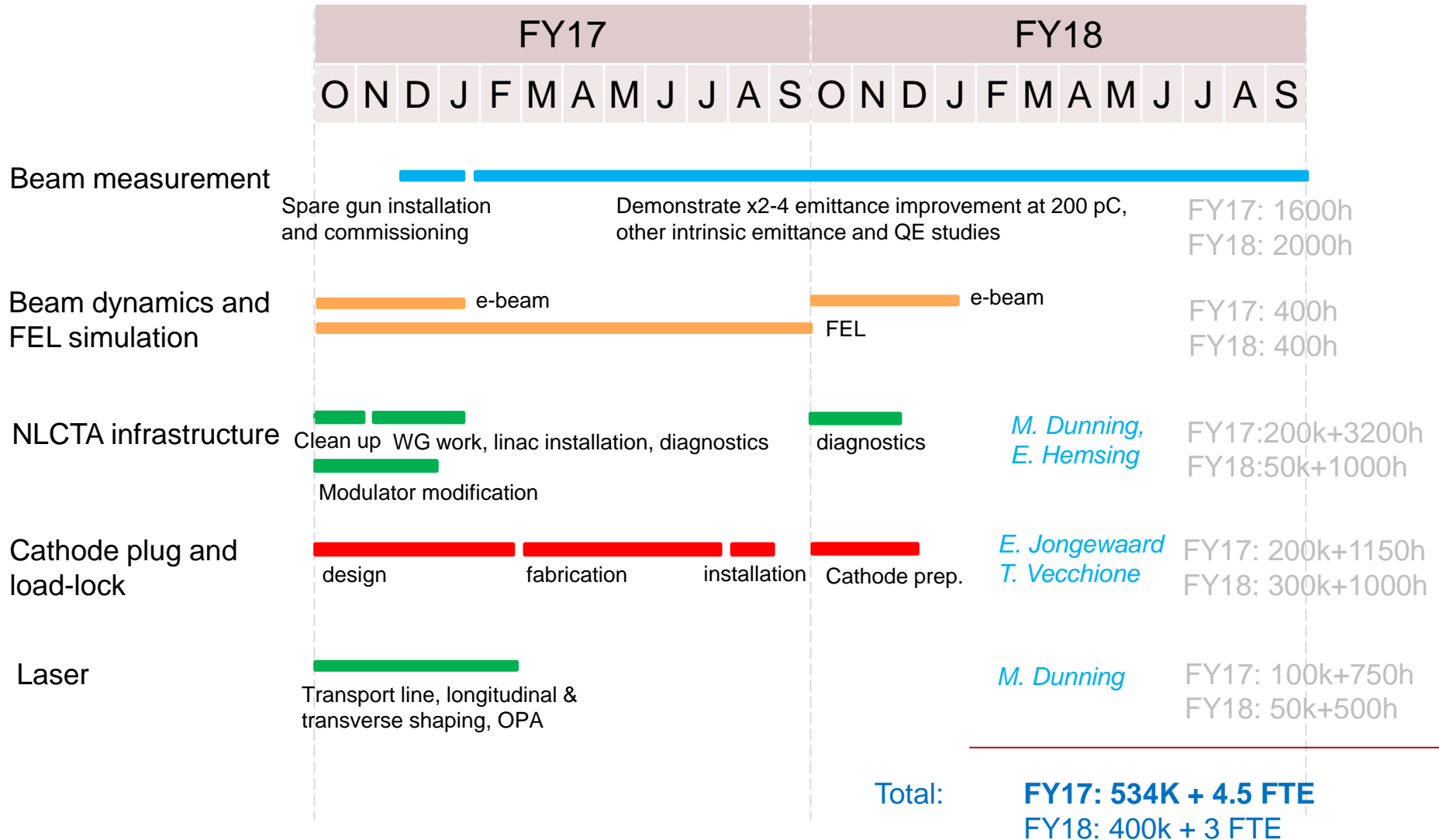


RF Gun Body



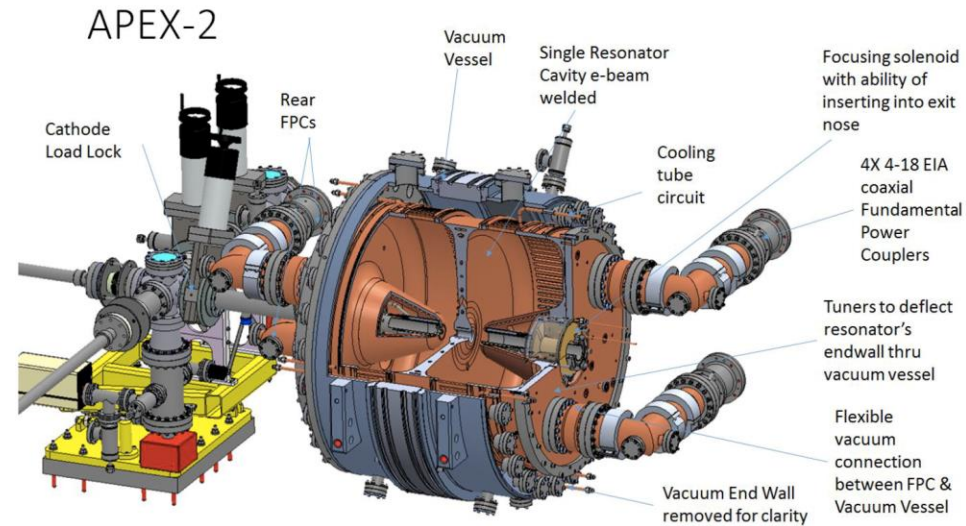
RF Cavity Probes

# Timeline and Resources

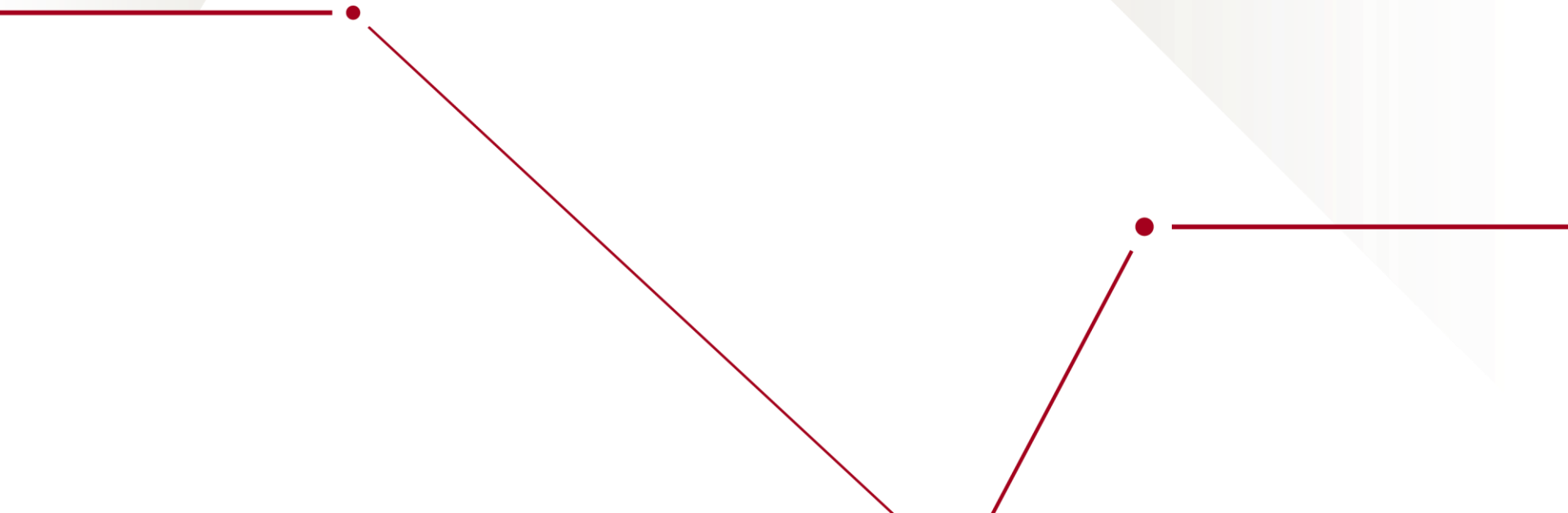


# Future

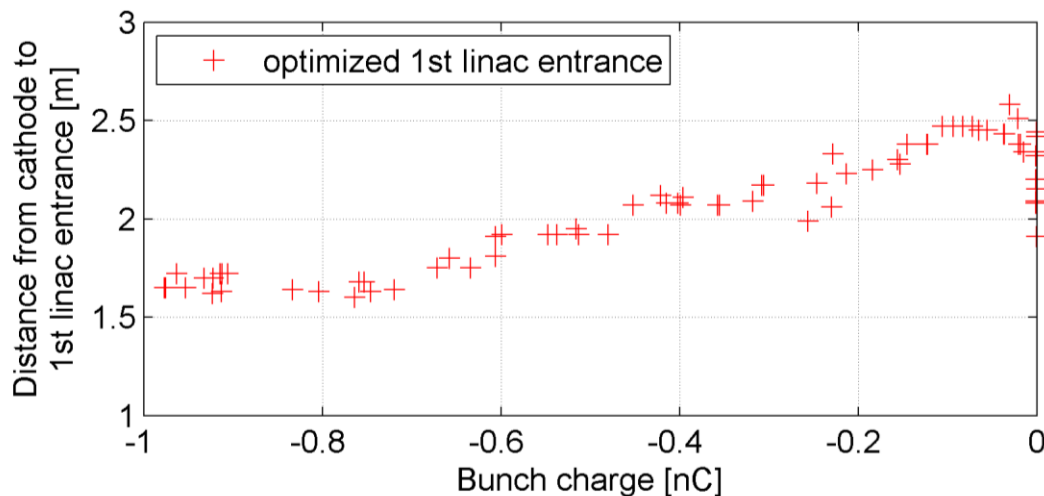
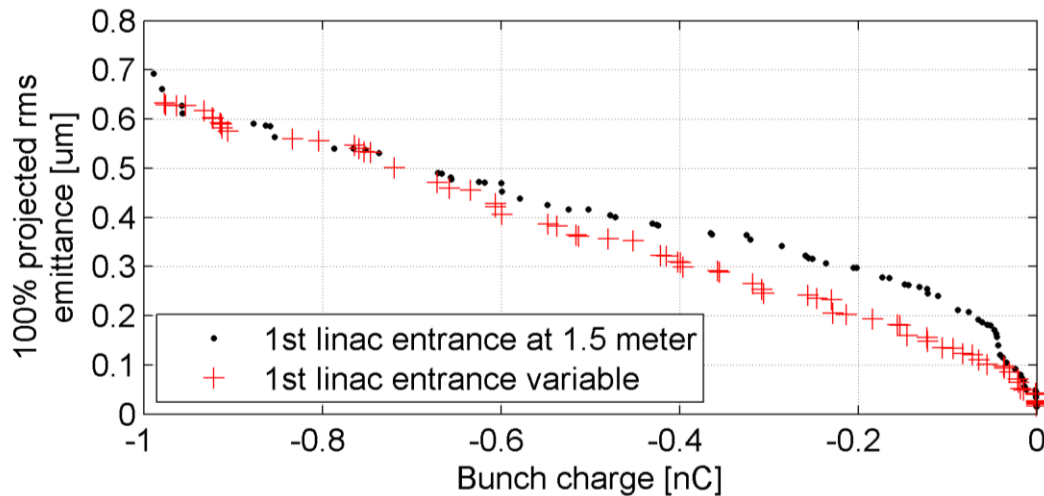
- Higher gradient CW guns
  - SRF - WiFEL gun now at SLAC
  - Room temperature guns can push gradient to approximately 30 MV/m such as APEX-2



***Thank you!***



# Injector location

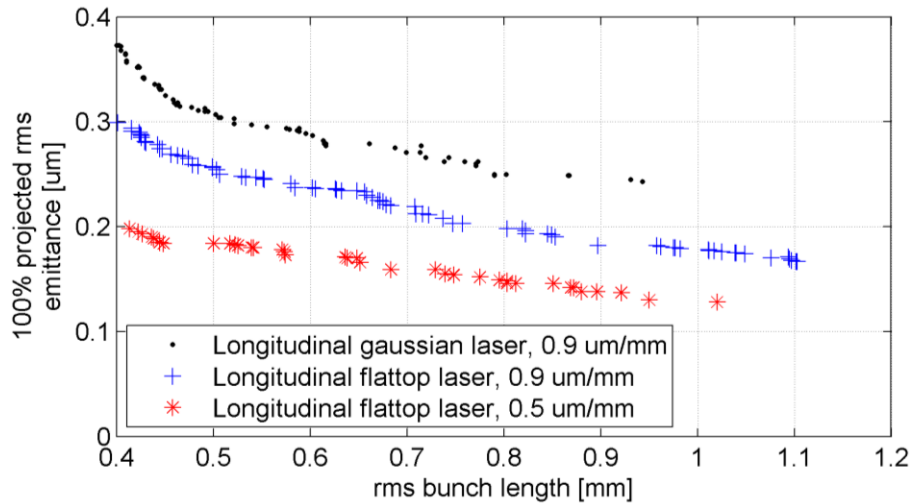


Injector layout optimizations (ASTRA simulations with 10 k macro particles), (a) Pareto front of emittance vs charge with rms bunch length shorter than 1 mm and injector beam energy above 100 MeV, (b) optimized location of first linac vs bunch charge.

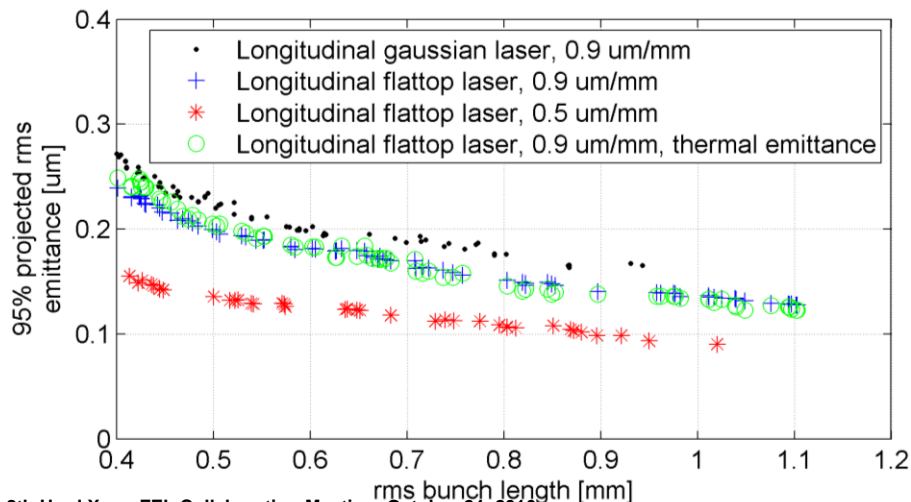
H. J. Qian et al., IPAC'16



# Emittance versus bunch length

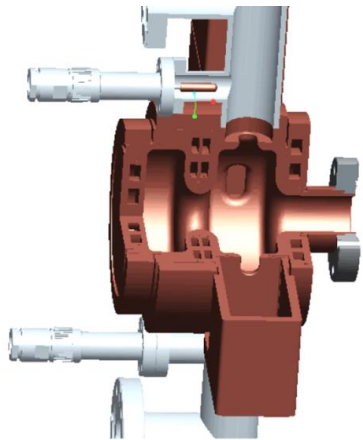


Pareto front of emittance vs rms bunch length for 200 pC bunch charge (ASTRA simulations with 10 k macro particles), (a) Pareto front of 100% emittance vs bunch length, (b) corresponding 95% emittance vs bunch length.



H. J. Qian et al., IPAC'16

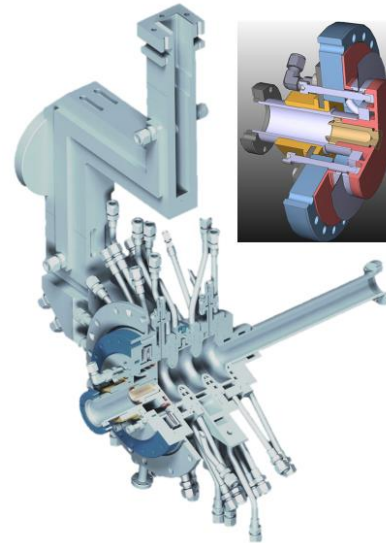
- PAL ITF (2012-2015)



- 1.5 cell, 60-120 Hz
- 120 MV/m
- 100 nm roughness Cu cathode w/ laser cleaning
- Linac entran. 2.2 m

- Commissioning status:  
 $\epsilon_{x/y} = 0.8/0.4 \text{ } \mu\text{m}$  at 200 pC

- PSI ITF (2012-2015)



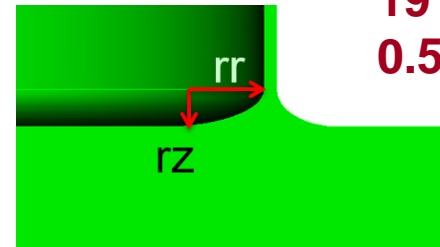
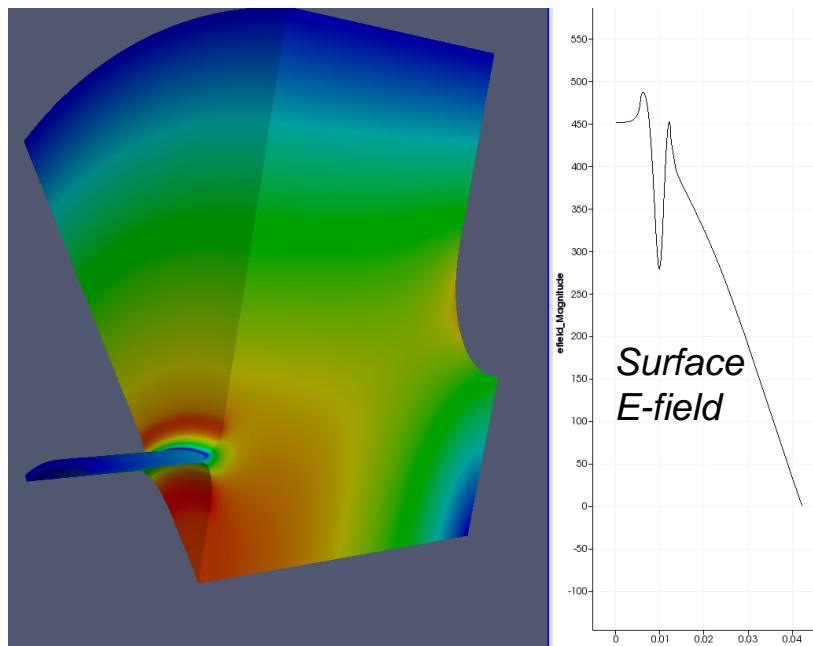
- 2.6 cell, 10-100 Hz
- 85-100 MV/m
- Cathode plug + load lock system
- 3 nm roughness Cu cathode w/o laser cleaning
- Cs<sub>2</sub>Te cathode
- Linac entran. 2.65 m

- Demonstrated  $\epsilon_{x/y} = 0.3 \text{ } \mu\text{m}$  at 200 pC and 20 A

# Optimize the cathode plug design

- Compatible with LCLS-II CW gun load-lock and preparation system
- Optimize rf and thermal design

19 mm diameter plug,  
0.5 mm gap (PSI, KEK)



rz	rr	$E_{Max}/E(r=0)$
0.25	0.25	1.77
0.5	0.5	1.41
1.0	1.0	1.30
1.5	1.5	1.26
1.5	2.5	1.15
1.5	4	1.08

PSI  
KEK

Z. Li